

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of	Docket No: Q85660
Heiji WATANABE, et al.	
Appln. No.: 10/521,311	
Confirmation No.: 1690	Group Art Unit: 2815
Filed: January 14, 2005	Examiner: WARREN, MATTHEW E
For: SEMICONDUCTOR DEVICE, AND MANUFACTURING METHOD AND MANUFACTURING APPARATUS OF THE SAME	

**AMENDMENT UNDER 37 C.F.R. § 1.114(c)**

**MAIL STOP RCE**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 1, 2008, please amend the above-identified application as follows on the accompanying pages.

**TABLE OF CONTENTS**

AMENDMENTS TO THE CLAIMS.....	2
REMARKS.....	22